Characterization of Ceramic GEM for The International Large Detector

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Outline



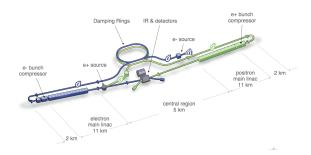
- Introduction
 - International Linear Collider (ILC)
- 2 LCTPC Lab at Siegen
 - Ceramic GEM
 - Test Chamber
- Measurements and Characterization
 - Long Time Stability
 - Repeatability
 - Maximum Gain
- 4 Summary



International Linear Collider (ILC)



- Electron positron collider
- Foreseen length: 31 km*
- Center of mass energy: 250 GeV to 500 GeV (1 TeV)
- Two foreseen detectors, one of them being the International Large Detector (ILD)
- Time Projection Chamber (TPC) as the tracker for the ILD
 - One of the candidates for electron multiplication: Gas electron multiplier (GEM)

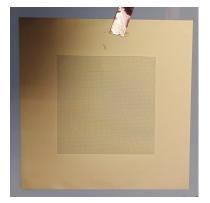




Ceramic GFM



- Motivation of use of ceramic: Resistance against melting.
- Avoid melting of the insulator with the heat emerging by discharges
- Produced by a Japanese Company named "KOA Corporation"
- Holes made by tipping



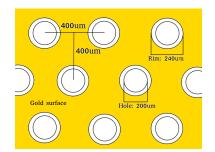
Ceramic GEM

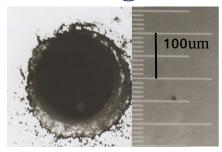
- Two batches of GEM
 - First batch: Without rim around the holes. Caused discharges at low voltages
 - Second batch: Rim included. Decreased probability of discharges



Ceramic GEM







Sketch of a ceramic GEM

A picture of a hole in a ceramic GEM

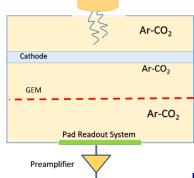
Properties	ceramic	CERN	
Size	50 <i>mm</i> × 50 <i>mm</i>	50 <i>mm</i> × 50 <i>mm</i>	
Thickness	$120 \mu m$	$50 \mu m$	
Conductor	Silver, Nickel and Gold	Copper	
Insulator	Ceramic	Kapton	
Holes diameter	$200\mu m$ (straight)	$50 - 70 \mu m \text{ (conic)}$	
Pitch	$400\mu m$	$140 \mu m$	
Ceramic hody	Glass-Alumina composite	n/a	

Test Chamber in Siegen



- Motivation: Smaller drift distance, higher drift fields.
- \bullet Small chamber (120 mm \times 184 mm)to measure the gain of GEMs.
- $\bullet~$ Gas mixture: $Ar-CO_2~(80\%-20\%)$ mixture.
- 5.9 keV X-ray source (⁵⁵Fe) for primary ionization.
- Drift field: 0.5 kV/cm, induction field: 2kV/cm.
- Pressure: Absolute air pressure
- Temperature: Room temperature

A scheme of the arrangement of the GEM inside the test chamber*

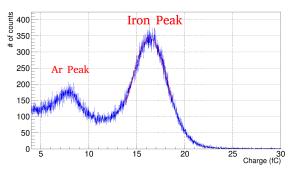


Fe⁵⁵



Gain Calculation





Signal with 2 peaks (Argon escape peak and ⁵⁵Fe peak).

Number of primary electrons:

 $G = n_t \times \frac{1}{n_0} = \frac{Q_t}{e} \times \frac{1}{216}$

$$n_p = \frac{5900 \text{ eV}}{26 \text{ eV}} \times 0.80 + \frac{5900 \text{ eV}}{34 \text{ eV}} \times 0.20 = 216$$

▶ 26eV and 34eV: Average energy per ionization for Ar and CO_2 respectively.

• Thus, the gain: ratio of total (n_t) to primary (n_p) electron number



Ceramic GFM Characterization

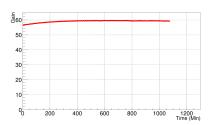


- Long time stability measurements
 - Operation stability
 - ► Gain stability
- Repeatibility of measurements
 - Comparison of measurements
 - ★ Challenges in comparison due to varying pressure and temperature
 - Adjustment of the gain to a chosen pressure and temperature using Garfield++ simulation data
- Achievable maximum voltage and gain

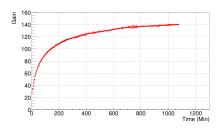


Long Time Stability





Long time measurement with CERN GEM at V_{GEM} =390 V.



Long time measurement with ceramic GEM at V_{GEM} =740 V.

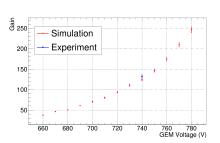
- The first important result of ceramic GEM: Charge up effect.
 - ► CERN GEM gain starts already from 95% of maximum gain
 - ▶ Gain stabilization of a ceramic GEM takes hours.



Garfield++ Simulations



- Field maps from ANSYS.
- Simulation with GEM specifications and geometries.
- Agreement within uncertanties (for the gains after stabilization)
- Pressure and temperature adjustment to compare measurements



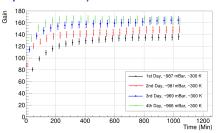
 $V_{\it GEM}$ vs. gain for ceramic GEM

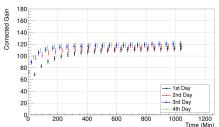
GEM	data	V_{GEM} (V)	P (Bar)	T (K)	Gain	$G_{\mathit{sim}}/G_{\mathit{meas}}$
CERN	experiment	390	0.987	298	59.64±2.17	
CERN	simulation	390	0.987	298	60.56 ± 1.15	1.015 ± 0.056
Ceramic	experiment	740	0.9875	299.5	131.2 ± 4.91	
Ceramic	simulation	740	0.9875	299.5	124.6 ± 3.13	$0.95{\pm}0.059$



Repeatability







Long time measurements before adjustment for 4 consecutive days with ceramic GEM at 740 V.

Long time measurements after adjustment at 740 V, 1 atm and 299.5 K.

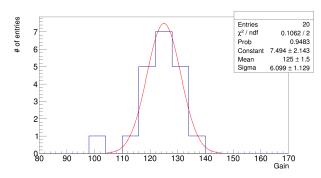
Time required for	1st Day	2nd Day	3rd Day	4th Day	3 Days Later
90% of max gain	258 min	132 min	93 min	69 min	189 min
95% of max gain	414 min	276 min	192 min	117 min	297 min

- Pressure and temperature adjusted to 1 atm and 299.5 K,
- Second important result: Conditioning
 - ▶ Increase of gain stabilization with consecutive measurements



Repeatability





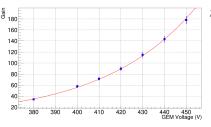
Distribution of gains from different measurements taken for 4 months of period

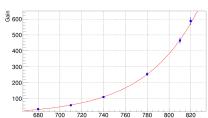
- Mean of the distribution of the adjusted gains (at 1 atm and 299.5 K) from different measurements: 125
- Variation within 68% inclusion area: $\sigma/\mu = 4.9\%$



Achievable Maximum Gain







CERN GEM voltage vs gain. 976 mBar and 301-302 K

Ceramic GEM voltage vs gain. 982-985 mBar and 300-301 K

- Achievable maximum voltage without discharges
 - for CERN GEM: 450 Vfor ceramic GEM: 820 V
- Gain at achievable voltage without discharges
 - for CERN GEM: 178for ceramic GEM: 586



Summary



- CERN GEM and ceramic GEM measurements have been performed.
- Measurements have been compared to Garfield++ simulations.
- Pressure and temperature adjustments for repeatability check of ceramic GEMs
 - ightharpoonup < 5% deviation between different measurements within 1σ
- Charging up effect observed. The gain of the ceramic GEM requires hours to become stabilized
- Conditioning observed. The ceramic GEM has a memory. Early reach of maximum gain if consecutive (HV) ramp-up and ramp-down performed.
- **Higher maximum safe gain.** The ceramic GEM has higher achieavable gain than in CERN GEM



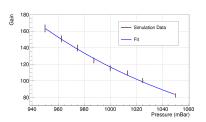
Backup



Pressure Adjustment



- Assumption for gain adjustment:
 - $G = e^{\alpha x}$ is valid
 - $\alpha = Ape^{-Bp/E} \propto p$ is valid
- Pressure adjustment fit function: $G = e^{sp+c}$
 - **▶** *s*: slope
 - c: constant

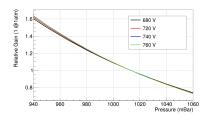


Fit on simulations of ceramic GEM at 740 V

• Gain adjustment (at 1 atm):

$$G_{corr} = \frac{G_{meas}(p)}{e^{sp+c}}$$

V_{GEM} (V)	slope (Bar^{-1})	constant
680	-6.44±4.5%	6.53±4.5%
720	-6.59±4.4%	6.68±4.4%
740	-6.72±4.5%	$6.81 \pm 4.5\%$
760	-6.69±4.8%	6.78±4.8%



Fits on simulations of ceramic GEM at different V_{GEM} universities of the siegen value of the siegen contains the siegen contains a s

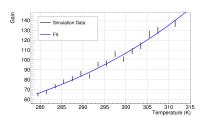
Temperature Adjustment



- Adjustment function by fitting simulation data
- Temperature adjustment fit function: $G = e^{sT+c}$

▶ *s*: slope

c: constant

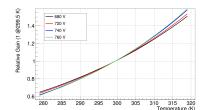


Fit on simulations of ceramic GEM at 740 V



$$G_{corr} = \frac{G_{meas}(T)}{e^{sT+c}}$$

V_{GEM} (V)	slope $(10^2 K^{-1})$	constant
680	2.11±2.2%	-6.32±2.2%
720	2.2±2.1%	-6.59±2.1%
740	2.35±3%	-7.03±3%
760	2.39±5.4%	-7.15±5.4%



Fits on simulations of ceramic GEM at different V_{GEM}

Gas System in Siegen



- The gas system includes a gas mixing system with desired percentages and a small chamber to monitor gas stabilization inside the experimental chamber
- After mixing process, gas mixture flows through the test chamber and/or the TPC prototype
- Later, the gas mixture flows to another chamber where we can monitor gas stabilization before it is released to air.



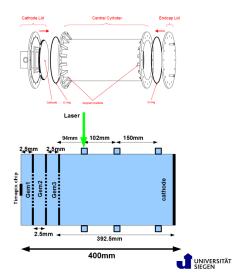


TPC Prototype in Siegen



In Siegen we have a cylindirical TPC prototype with $240\,mm$ diameter and $400\,mm$ length

- As readout detector, it has a TimePix chip which has 256×256 pixel resolution with $55 \mu m \times 55 \mu m$ pixel size
- The TimePix chip is controlled via FPGA card and signal is recorded in a matrix form which inludes possible tracks of electrons
- To be able to start primary ionization, a UV laser and beta-ray source are used in 3 entry holes.





- -Pressure of the gas mixture is slightly higher than absolute air pressure.
- -Thus, absolute air pressure can be used as gas pressure since pressure difference is negligible
- -Absolute air pressure is measured by a pressure sensor (MS5611-01BA01)
- -Temperature is measured built-in temperature sensor of the pressure sensor



